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Detector Module: Inspection and Test Plan: update



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Outline

- Overview of Detector Module ITP;
- Baselined tasks:
 - OB module air tightness;
 - Disk module: carbon fibre plate;
 - Powering tests on detector modules;
- Open points:
 - Acceptance tests of LAS and AncAsic;
 - Grounding AncAsic – LAS;
- Conclusion;

Detector Module Inspection and Test Plan

Author Names

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Institution(s)

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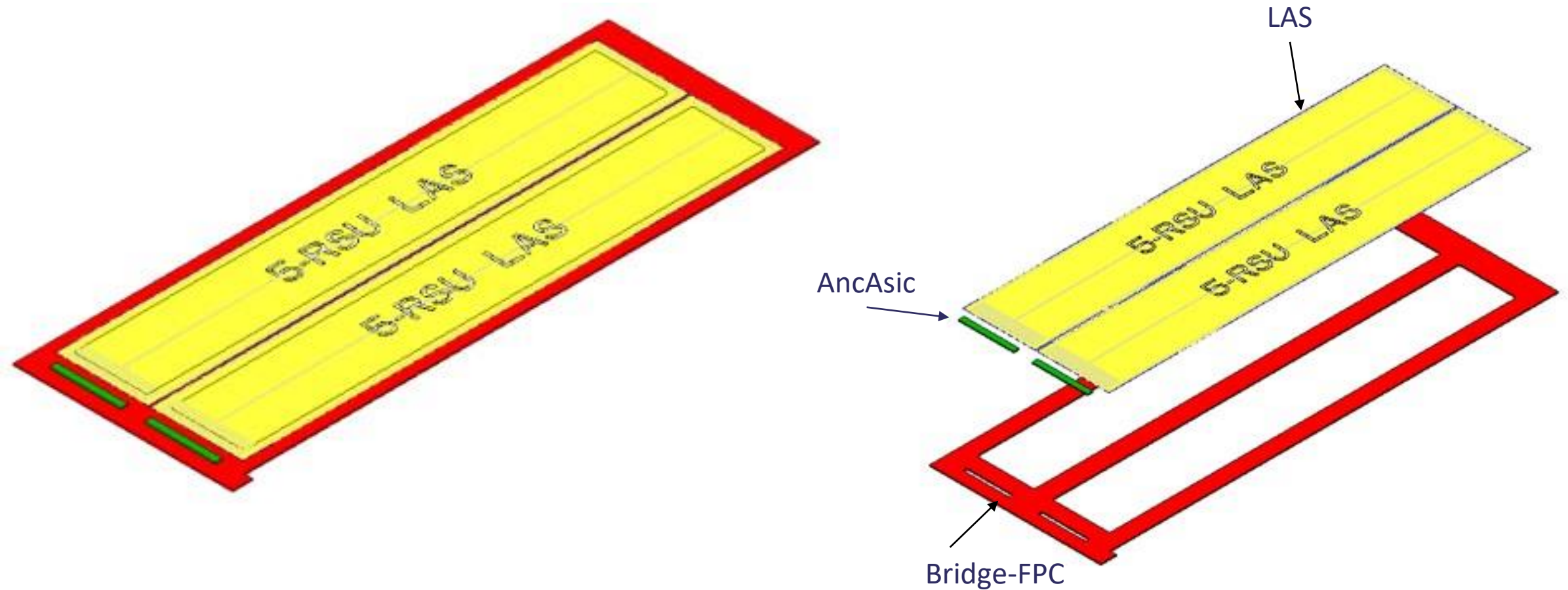
2- University of Birmingham [UK]

3- University of Liverpool [UK]

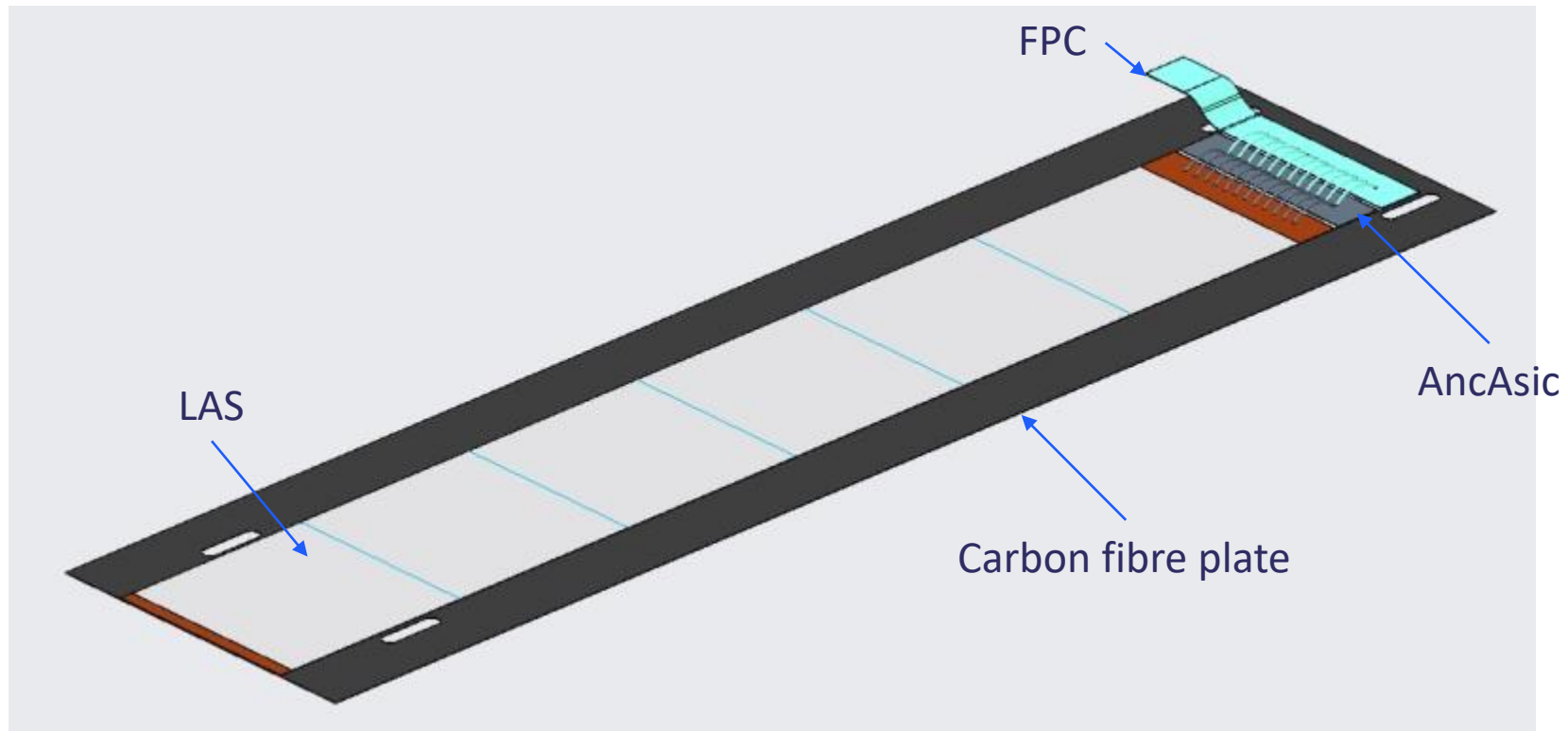
Abstract

Detector modules for Outer Barrels and Endcaps are pre-assembled and pre-tested and then mounted and electrically interlinked in the final staves and disks. Detector modules are electrically self-contained units. They break-down by design the complexity of a stave and a disk into sub-units. This is beneficial in order to identify faults and rework and reject units before their mounting on staves or disks.

Detector module: barrels



Detector module: endcaps



ITP overview

Contents

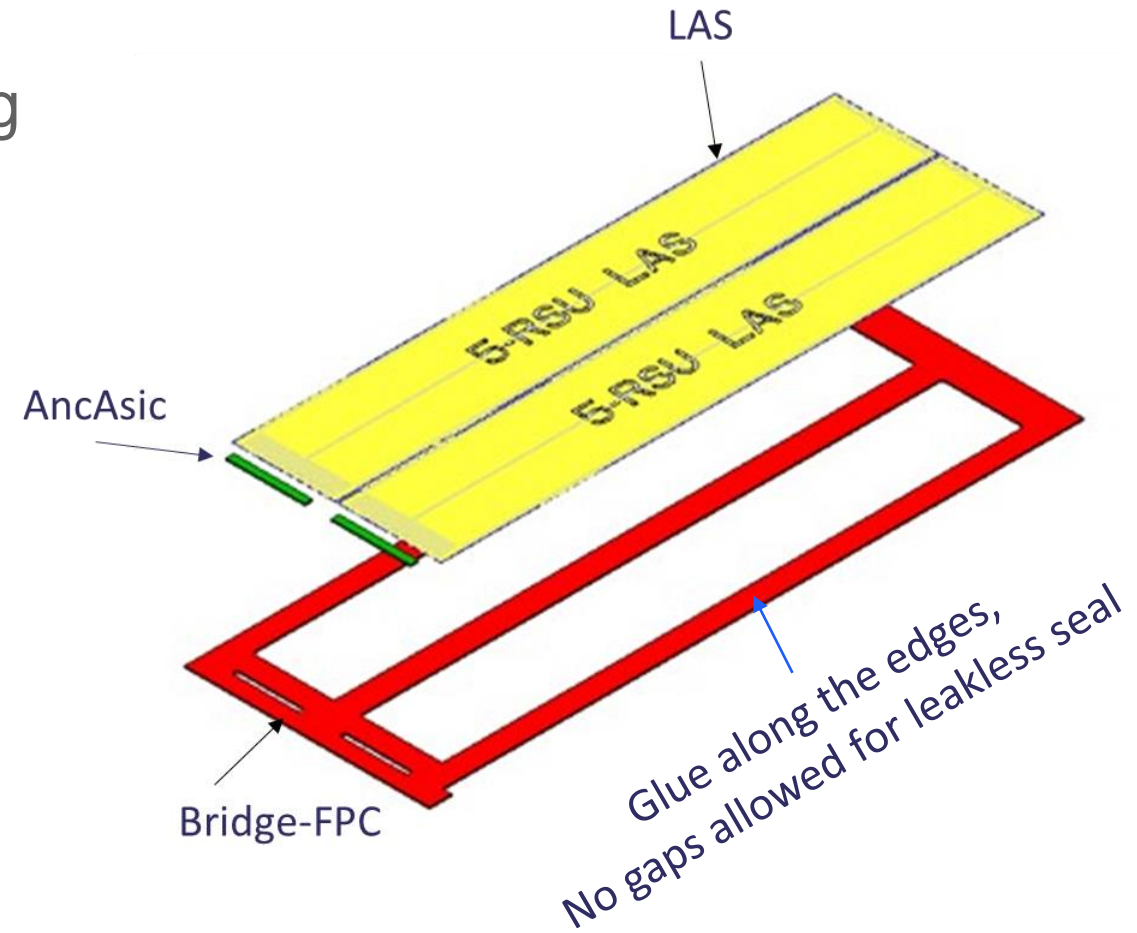
1. Detector Module Properties	1	3. Experimental/Test Setups	5
2. Processes and Procedures.....	2	3.1. Post-assembly: Mechanical tests.....	5
2.1. Pre-assembly: Workspace, equipment and storage.....	2	3.1.1. Resource Requirements.....	6
2.1.1. Verification Testing	2	3.1.2. Test Conditions	6
2.2. Pre-assembly: Components acceptance testing.....	3	3.1.3. Equipment	6
2.2.1. Incoming Inspections or Acceptance Testing	3	3.2. Post-assembly: Electrical tests.....	6
2.3. Post-assembly: Mechanical test: Mechanical integrity and alignment of module components.....	3	3.2.1. Resource Requirements.....	6
2.3.1. Verification Testing	3	3.2.2. Test Conditions	6
2.4. Post-assembly: Mechanical test: Welding integrity of microelectronics interconnects.....	3	3.2.3. Equipment	6
2.4.1. Verification Testing	3	4. Environment, Safety & Health Considerations.....	7
2.5. Post-assembly: Electrical test: AncASIC: Powering test.....	3	5. Records and Documentation.....	7
2.5.1. Verification Testing	4		
2.6. Post-assembly: Electrical test: AncASIC: Digital communication tests.....	4		
2.6.1. Verification Testing	4		
2.7. Electrical test: EIC-LAS: Powering tests.....	4		
2.7.1. Verification Testing	4		
2.8. Post-assembly: Electrical test: EIC-LAS: Digital communication tests.....	4		
2.8.1. Verification Testing	5		
2.9. Post-assembly: Electrical test: EIC-LAS: In-pixel tests	5		
2.9.1. Verification Testing	5		
2.10. Post-assembly: Electrical test: EIC-LAS: Noise occupancy tests.....	5		
2.10.1. Verification Testing	5		

- First version shared with reviewers on 21/11/2025.
- Discussions, investigations, changes.
- Latest release distributed on 05/12/2025 (only to LG).

Baselined items

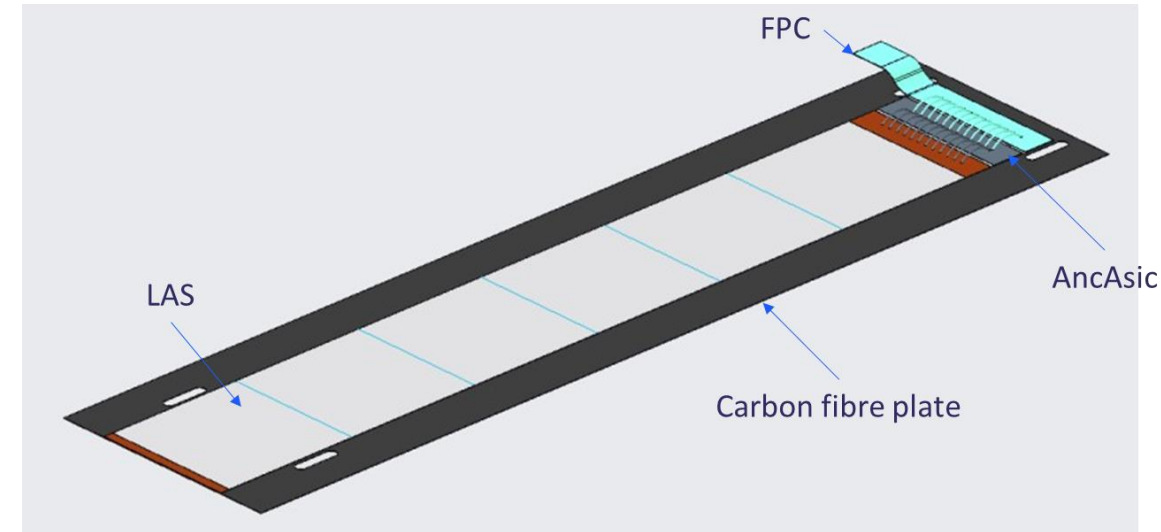
OB module: air tightness

- This is about uniformity of glue distribution along the edges of Si chips.
- Difficult and impractical test to do
 - To fix by design.
- Use “design for manufacturing principle” to remove the need of this test.
- To modify design to avoid this test:
 - Mods mainly affect FPC design



Disk module: carbon fibre plate (CFP)

- This is about avoiding shorts between carbon fibre support and LAS.
- Quality of manufacturing of CFP.
- Mitigation factors during module assembly, like epoxy selection and distribution (LAS CFP interface).

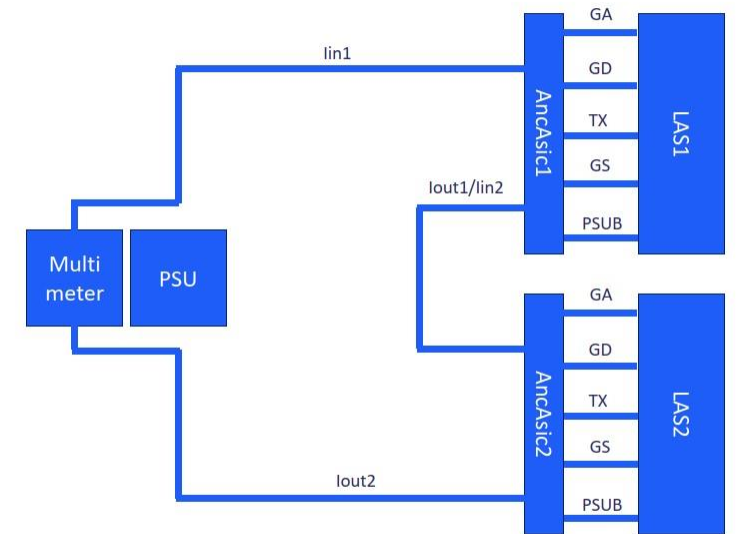


Powering tests on detector modules

Captured in dedicated presentation.

Step0 - power off

Probe lines to detect shorts or opens.



See my set of slides on powering tests

Open points

Acceptance tests on LAS and AncAsic

Principle:

Need a reliable assessment of the chip quality before module assembly.

Criteria:

- Mechanical integrity [e.g. metrology on dimensions] ← How critical are the dimensions for us?
(A topic of its own?)
- Electrical integrity

Current workflow:

- Wafers are probe tested at delivery from the foundry.
[Assess processing yield from foundry]
- Post-processing: wafers are sent to thinning and dicing. ← Post processing yield for 50um thin Si chips?
(yield of thinning to 50 um thick chips)
- Chips are sent to module assembly.

ALICE ITS2 – case study

+ spin-outs e.g. SPHENIX MVTX, R3B-TRT

See ALICE ITS2 TDR (page 46 "3.2 Thinning and dicing", page 48 "3.3 Single chip tests"):

<https://iopscience.iop.org/article/10.1088/0954-3899/41/8/087002/pdf>



[...] The wafers will be post-processed, thinned and diced to obtain individual Pixel Chips. **Each chip will be tested and inspected prior to the assembly into larger modules.** [...]

[Dimensional compliance is important for this detector].

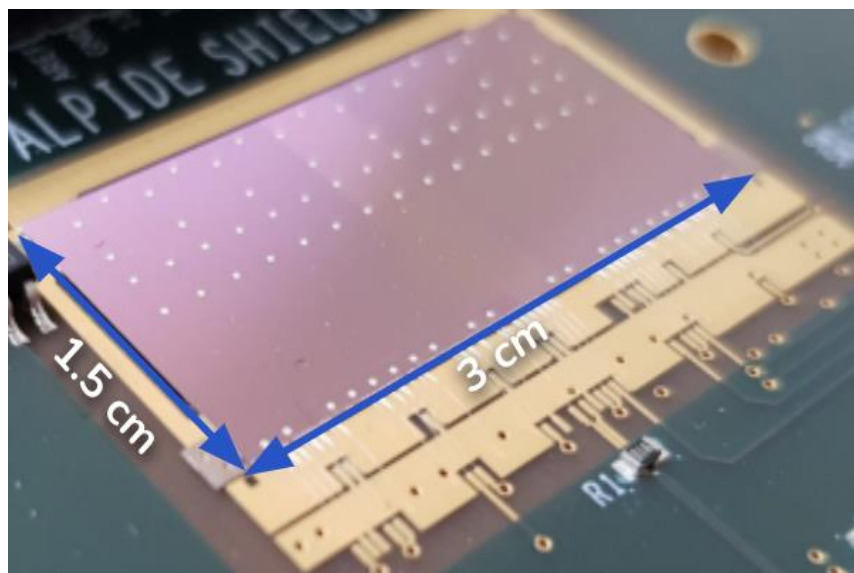
[...] The exact yield factors for each of the processing steps (production, dicing, thinning, etc.) prior to the single chip tests are not yet known.[...]



ALPIDE yield (average)

sensors/wafer	46
gold [%]	30
silver [%]	30
bronze [%]	7.5
mech. grade [%]	32.5

} Not considered suitable parts for detector grade modules



STAR PXL – case study

Do acceptance tests at module assembly sites?

See “The MAPS based PXL vertex detector for the STAR experiment”
“3 Detector production” page 3

<https://iopscience.iop.org/article/10.1088/1748-0221/10/03/C03026/pdf>

[...] **The 50 μ m thinned and diced sensors**, typically curved due to their reduced thickness, **are positioned on a custom made vacuum chuck and contacted through pins**, which are mounted on a dedicated electronics probe card and designed to deal with the uneven pad ring surface: **the sensor is tested for functional operation**, fully characterized in terms of noise and operating thresholds through built-in test functionalities and the readout is tested at full speed (160 MHz). **The yield of sensors within specifications ranged from 46% to 60% throughout the probe testing campaign** [...]

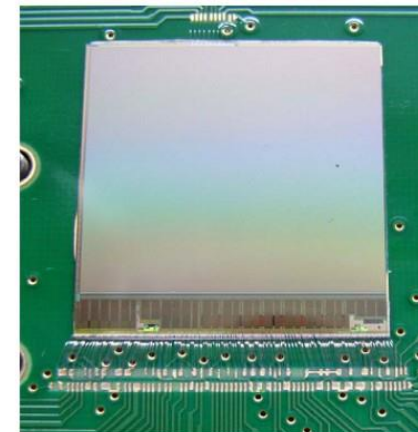
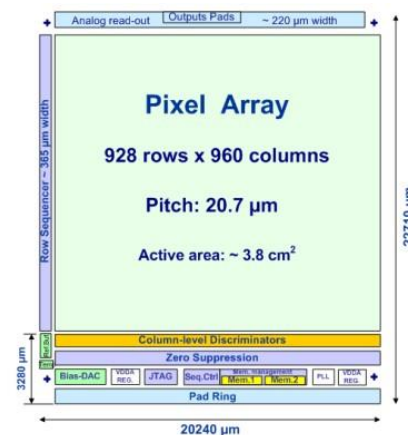


Figure 1. Functional block diagram of ULTIMATE (left) and Picture of the sensor on its PCB (right).

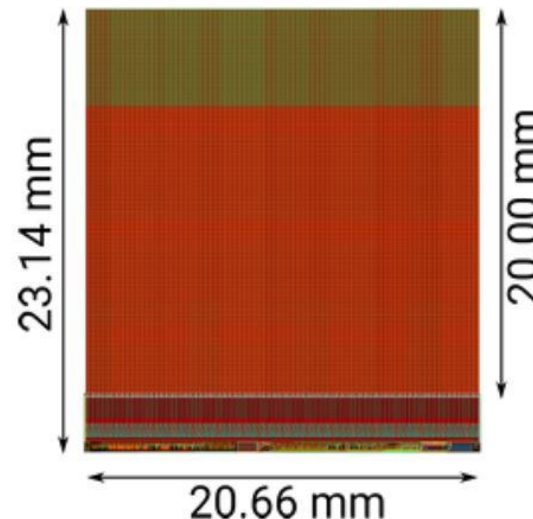
Mu3e – case study

See “Technical design of the phase I Mu3e experiment”

“7.4. Pixel tracker construction and quality control” page 19

<https://www.sciencedirect.com/science/article/pii/S0168900221006641>

[...] In case of the MuPix chips, **electrical testing** will take place on the wafer, and **on single die after dicing**, using appropriate probe cards [...]



50um thin

Fig. 2. The MuPix10 layout: Active matrix at the top and periphery at the bottom. The color change in the active matrix is a feature of the routing scheme, see section 4.5

CBM MVD – case study

See “The prototype of the Micro Vertex Detector of the CBM Experiment” “2.1. Sensor integration”
<https://www.sciencedirect.com/science/article/pii/S0168900213010504>

2013

[...] The sensors were only visually inspected prior to assembling [3] but electrical tests were done only after bonding [...]
[3] - Probe tests were not performed since probe cards had not been delivered in time.

[...] However, accounting for **a yield of 65% after sensors thinning** given by the sensor supplier, the assembly process was not observed to significantly further reduce this yield [...]

2022

InformationReferences (0)Citations (0)KeywordsUsage statisticsFilesPlotsHoldings

ReportGSI-2022-00549

Technical Design Report for the CBM: Micro Vertex Detector (MVD)

Klaus, P. (Editor) ; Koziel, M. (Editor) ; Michel, J. (Editor) ; Muentz, C. (Editor) ; Stroth, J. (Corresponding author) ; Deveaux, M.

2022
CBM Collaboration

CBM Collaboration 157 p. (2022)

Report No.: 1

Abstract: Approved Technical Design Report for the Micro Vertex Detector of the Compressed Baryonic Matter experiment at FAIR.

Note: BMBF ErUM-FSP-T06: C.B.M.@FAIRBilateral Contract GSI – Goethe University FrankfurtHIC for FAIRHelmholtz Forschungsakademie Hessen fuer FAIRIN2P3-IPHC Strasbourg

<https://repository.gsi.de/record/246516>



Acceptance tests on LAS and AncAsic?

- **Consistent approach in literature** on sensor probe testing after thinning and dicing.
- **SVT has a different approach** from the standard in our field, is it relaxing QC on parts?
- **Potential negative impact on detector module production** for SVT barrels and disks.

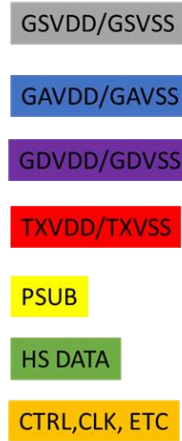
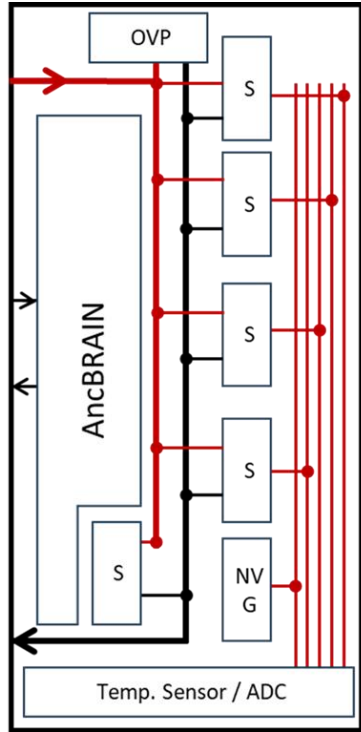
Is wafer thinning and dicing understood to the necessary level?

LAS areas will be ~5 or ~6 times grater than ALPIDE or Ultimate... potential for lower yield after thinning and dicing?

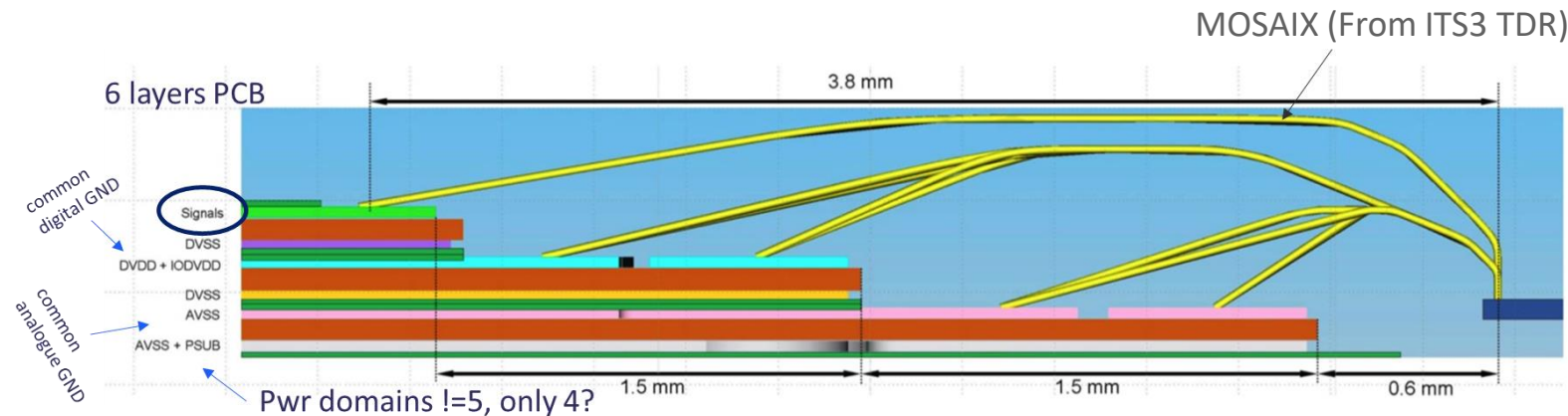
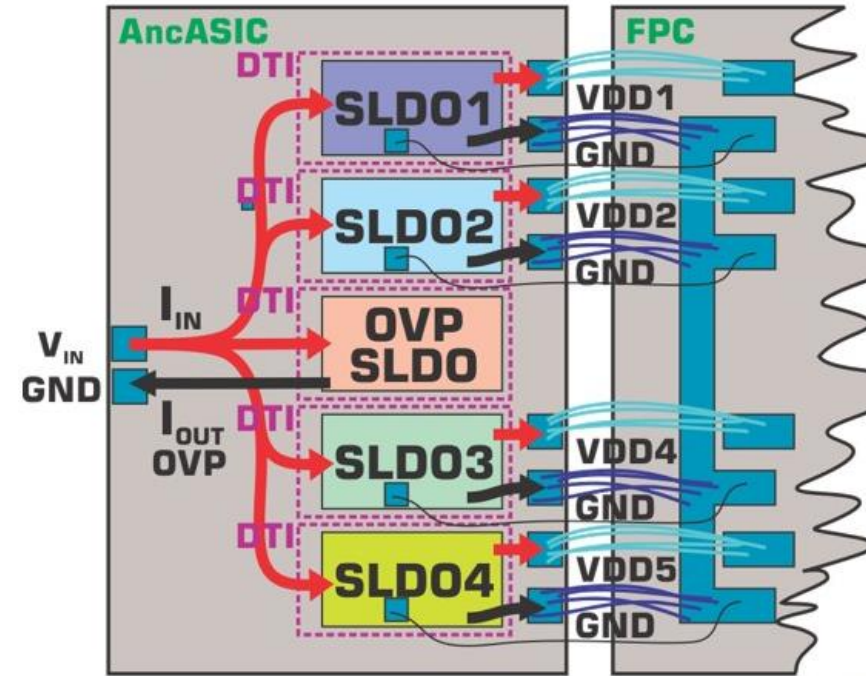
Grounding: AncAsic – LAS

Common gnd? **Yes?**

Or common analogue gnd
and common digital gnd? **No?**



G.Deptuch <https://indico.bnl.gov/event/30317/>



Conclusion

- Latest release of ITP was edited following comments from reviewers: Laura, Nikki, Vallary, Iain.
- ITP and module benefitted from this exercise, which contributed to increase their maturity.



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Thank you

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Twitter: @STFC_matters

YouTube: Science and
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Detector module: endcaps

